### THE UNITED STATES PATENT AND TRADEMARK OFFICE

# REVOCATION AND NEW POWER OF ATTORNEY AND CHANGE OF CORRESPONDENCE ADDRESS

I, Dr. Graham Fisher, Director of Intellectual Property of MEMC Electronic Materials, Inc., the Assignee of the entire right, title, and interest in the U.S. Patent Application(s) and/or Patent(s) identified on the attached Schedule A, hereby revoke all previous powers of attorney or authorizations of agent given and do hereby appoint the attorneys or agents associated with the following Customer Number, with full power of substitution and revocation, to prosecute and transact all business in the Patent and Trademark Office connected therewith for the U.S. Patent Application(s) and/or Patent(s) listed in the attached Schedule A:

Customer Number: 76681

Please direct all correspondence in connection with said U.S. Patent Application(s) and/or Patent(s) to:

Customer Number: 76681

Respectfully submitted,

Dr. Graham Fisher
Director of Intellectual Property
MEMC Electronic Materials, Inc.

## THE UNITED STATES PATENT AND TRADEMARK OFFICE

### STATEMENT UNDER 37 CFR 3.73(b)

MEMC Electronic Materials, Inc., a Delaware Corporation, pursuant to 37 CFR 3.73(b), hereby states that it is the Assignee of the entire right, title, and interest in U.S. Patent Application(s) and/or Patent(s) on the attached Schedule A.

The entire rights, title, and interest in the aforementioned Patent Application(s) and/or Patent(s) were conveyed to MEMC Electronic Materials, Inc. via Assignment(s) recorded with the United States Patent and Trademark Office at the Reel/Frame Numbers on the attached Schedule A.

The undersigned, Dr. Graham Fisher, Director of Intellectual Property, has full authorization to act on behalf of Assignee MEMC Electronic Materials, Inc.

Respectfully submitted,

Date: 5/13/2008

Dr. Graham Fisher

Director of Intellectual Property
MEMC Electronic Materials, Inc.

# APPENDIX A Owned by MEMC Electronic Materials, Inc.

ATTORNEY REFERENCE	CONF. NO	PUBLICATION NO. & DATE	SERIAL NO. FILING DATE	PATENT NO. ISSUE DATE	CURRENT OWNER/ ASSIGNEE	REEL AND FRAME NO.	ште
28744-215 (MEWC2905.16)	4312	US2007-0169693-A1 7/26/2007	11/823,142 V15/2007		MEMC Electronic Materials, Inc.	Division of 10/330,806 recorded at 014339/0912	NITROGEN-DOPED SILICON SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FALLTS
MEMI02905.9	1990	US-2004-0009111-A1	10/380,806 7/30/2003	7,182,809	MEMC Electronic Materials, Inc.	014339/0812	NITROGEN-DOPED SILICON SUBSTANTIALLY FREE OF OXIDATION INDUCED STACKING FAULTS
MEMC2907.1	3890	US-2003-0079673-A1 5/1/2003	10/281,632 10/28/2002	6,866,713 3/15/2005	MEMC Electronic Materials, frec.	013562/0482	SEED CRYSTALS FOR PULLING SINGLE CRYSTAL SILICON
MEMC2960.1	5778	US-2002-0100410-A1 811/2002	10/054,629 1/22/2002	6,846,539 1/25/2005	MEMO Electronic Materials, Inc.	012769/0747	LOW DEFECT DENSITY SILICON HAVING A VACANCY. DOMINATED CORE SUBSTANTINLLY FREE OF OXIDATION INDUCED STACKING FAULTS
MEMC2960.9		US-2005-0150445.A1 7/14/2005	111005,987 12[7/2004	7,217,320 5/15/2007	MEMC Electronic Materials, Inc.	Division of 10/054,629 recorded at 012769/0747	DOMINATED CORE SUSTRANTICLY FREE OF OXIDATION INDUCES A VACANCY- DOMINATED CORE SUSTRANTICLY FREE OF OXIDATION INDUCED STACKING FAULTS
MEMC2970.1	4314	US-2003-0061985-A.1 4/3/2003	10,256,759	7,432,091	MEMC Electronic Materials, inc.	013576/0951[	SINGLE CRYSTAL SILICON INGOT MAVING A HIGH ARSENIC CONCENTRATION
MEWC2964.10	100	US-2005-0258671-41 1111772005	111774,908 7/5/2005	7,971,080	MEMO Electronic Malenals, Inc.	Division of 10/177,444 reported at 013181/0822	PROCESS FOR PRODUCING SILICON ON INSULATOR STRUCTURE HAVING INTRINSIC GETTERING BY ION IMPLANTATION
MENC2994.2	5976	US-2003-0008435-A1 1/9/2003	10/177,444	6,960,375	MEMO Electronic Materials, Inc.	013181/0822	SILICON ON INSULATOR STRUCTURE HAVING AN EPITAXIAL LAYER AND INTRINSIC GETTERING
MEM02992	2873	US-2003-0068958-A1 4/10/2003	69/682,677 10/4/2001	6,712,673	MEMC Electronic Materials, inc.	012329/0298	POLISHING APPARATUB, POLISHING HEAD AND METHOD
MEMOSODA 1D	2878	US-2005-0048247-A1 3/3/2005	10/962,340	7,201,500	MEMC Electronic Materials, Inc.	Division of 10/963,340 moorded at 91.2923/0124	PROCESS FOR MAKING SILICON WAFERS WITH STABILIZED OXYGEN PRECIPITATE NUCLEATION CENTERS
MEMC3804.2	8328	US-2003-0138961-A1 724/2003	10328,481	6,808,781 10/26/2004	MEMC Electronic Materials, Inc.	0139230324	SILICON WAFERS WITH STABILIZED OXYGEN PRECIPITATE NUCLEATION CENTERS AND PROCESS FOR MAKING THE SAME.
MEMC3005.3	1197	US-2004-0118333-A1 6/24/2004	10/699,038 10/31/2003	7,125,450 10/24/2006	MEMC Electronic Materials, Inc.	2004/0118333	PROCESS FOR PREPARING SINGLE CRYSTAL SILICON USING CRUCIBLE ROTATION TO CONTROL TEMPERATURE GRADIENT
MEMC3007	2404	US2004-0255847 A1 1283/2004	10/465,528 6/19/2003	6,942,733	MEMC Electronic Materials, Inc.	019911/0117	FLUID SEALING SYSTEM FOR A CRYSTAL PULLER
28744-107 (MEMC3011.1)	6422	US-2003-0192469-A1 10/16/2003	10/22/2002		MEMC Electronic Malerials, Inc.	2003/0192469	PROCESS FOR CONTROLLING DENUDED ZONE DEPTH IN AN IDEAL OXYGEN PRECIPITATING SELCON WAFER
28744-138 (MEMC3035.1)	5409	US-2004-0112277-A1 8H722004	10705,813		MEMC Electronic Materials, Inc.	20040013277	ORYSTAL PULLER AND METHOD FOR GROWING A MONOCRYSTALLINE INGOT
MEMC3043	3340		08/345,695 11/30/1994	5,698,045	MEMC Electronic Materials, Inc.	00732140390	PROCESS FOR STRIPPING OUTER EDGE OF BESO! WAFERS